

Reflection from metals

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Fresnel approximation

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We've talked about reflectance and transmittance from dielectrics. We also need to take a long look in the mirror and consider how light waves interact with conductors, which obey Ohm's law of $I = (1/R)V$ or $J = \sigma E$ in terms of a current density J , electric field E , and conductance σ . With this, Maxwell's equations in 1D become

$$\frac{\partial^2}{\partial x^2} E = \mu\epsilon \frac{\partial^2 E}{\partial t^2} + \mu\sigma \frac{\partial E}{\partial t} \quad (1)$$

$$\frac{\partial^2}{\partial x^2} B = \mu\epsilon \frac{\partial^2 B}{\partial t^2} + \mu\sigma \frac{\partial B}{\partial t} \quad (2)$$

Since E and B have the same form, we'll consider E only in what follows. We'll now do our usual thing of considering solutions of the form $E = E_0 e^{-i(kx - \omega t)}$.

Some conductivities σ in $1/(\Omega \cdot \text{meters})$: undoped silicon 1.2×10^3 , aluminum 3.77×10^7 , copper 5.96×10^7 , silver 6.30×10^7 .

Aluminum: magnetic susceptibility is $\chi_m = (\mu/\mu_0 - 1) = 2.1 \times 10^{-5}$.

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To consider solutions of the form $E = E_0 e^{-i(kx - \omega t)}$, we need to take some derivatives:

$$\begin{aligned}\frac{\partial}{\partial t} E &= (i\omega) E_0 e^{-i(kx - \omega t)} \\ \frac{\partial^2}{\partial t^2} E &= \frac{\partial}{\partial t} (i\omega) E_0 e^{-i(kx - \omega t)} = (-\omega^2) E_0 e^{-i(kx - \omega t)} \\ \frac{\partial}{\partial x} E &= (-ik) E_0 e^{-i(kx - \omega t)} \\ \frac{\partial^2}{\partial x^2} E &= \frac{\partial}{\partial x} (-ik) E_0 e^{-i(kx - \omega t)} = (-k^2) E_0 e^{-i(kx - \omega t)}\end{aligned}\tag{3}$$

We can use these results for expanding Eq. 1:

$$\begin{aligned}\frac{\partial^2}{\partial x^2} E &= \mu\epsilon \frac{\partial^2 E}{\partial t^2} + \mu\sigma \frac{\partial E}{\partial t} \\ (-k^2) E_0 e^{-i(kx - \omega t)} &= (-\omega^2) \mu\epsilon E_0 e^{-i(kx - \omega t)} + \mu\sigma (i\omega) E_0 e^{-i(kx - \omega t)}\end{aligned}\tag{4}$$

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From the differential equation of Eq. 4, we have

$$\begin{aligned}k^2 &= \omega^2 \mu \epsilon - i \omega \mu \sigma \\k &= \omega \sqrt{\mu \epsilon} \sqrt{1 - i \frac{\sigma}{\omega \epsilon}} = k_r - i k_i\end{aligned}\tag{5}$$

so that wave propagation becomes

$$E_0 e^{-i(kx - \omega t)} = E_0 e^{-i(k_r x - \omega t)} e^{-k_i x}\tag{6}$$

with a phase velocity of $v_p = \omega/k_r$ and an amplitude attenuation of $e^{-k_i x}$.

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Again, we had from Eq. 5 the form

$$k = \omega \sqrt{\mu \epsilon} \sqrt{1 - i \frac{\sigma}{\omega \epsilon}} = k_r - i k_i$$

How should we handle the factor $\sqrt{1 - i\sigma/(\omega\epsilon)}$? At optical frequencies ($\lambda = 500$ nm corresponds to $\omega = 2\pi c/\lambda = 3.8 \times 10^{15}$ rad/sec), let's consider values for two different materials:

$$\text{Aluminum: } \frac{\sigma}{\omega \epsilon_0} = \frac{3.77 \times 10^7}{3.8 \times 10^{15} \cdot 8.85 \times 10^{-12}} = 1.1 \times 10^3$$

$$\text{Undoped silicon: } \frac{\sigma}{\omega \epsilon} = \frac{1.2 \times 10^3}{3.8 \times 10^{15} \cdot 16 \cdot 8.85 \times 10^{-12}} = 2.2 \times 10^{-3}$$

where for silicon we have a dielectric constant of $k = \epsilon/\epsilon_0 = 16$. As you can see, we have two entirely different limits for $\sqrt{1 - i\sigma/(\omega\epsilon)}$.

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Let's first consider the case of low conductivity $\sigma \ll \omega\epsilon$, such as the case of undoped silicon. In that case, we can approximate k from Eq. 5 as

$$k = \omega\sqrt{\mu\epsilon}\sqrt{1 - i\frac{\sigma}{\omega\epsilon}} \simeq \omega\sqrt{\mu\epsilon}\left(1 - i\frac{\sigma}{2\omega\epsilon}\right) \quad (7)$$

where we've used the binomial expansion. The phase velocity then becomes

$$v = \frac{\omega}{k_r} = \frac{\omega}{\omega\sqrt{\mu\epsilon}} = \frac{c}{n} \quad (8)$$

but the light intensity is attenuated according to $(e^{-k_i x})^2 = e^{-2k_i x}$ with a $1/e$ attenuation distance of

$$\frac{1}{2k_i} = \frac{2\omega\epsilon}{\omega\sigma\sqrt{\mu\epsilon}} = \frac{2}{\sigma} \sqrt{\frac{\epsilon}{\mu}}. \quad (9)$$

For undoped silicon, $1/(2k_i) = 4.4 \times 10^{-6}$ m or $4.4 \mu\text{m}$.

Metals: high conductivity limit

If instead we consider the high conductivity limit of $\sigma \gg \omega\epsilon$ (which we saw earlier was the case for aluminum), we can approximate k from Eq. 5 as

$$k = \omega\sqrt{\mu\epsilon}\sqrt{1 - i\frac{\sigma}{\omega\epsilon}} \simeq \omega\sqrt{\mu\epsilon}\sqrt{-i\frac{\sigma}{\omega\epsilon}} = \sqrt{-i\sigma\mu\omega}. \quad (10)$$

Now $\sqrt{-i} = \sqrt{e^{-i\pi/2}} = (e^{-i\pi/2})^{1/2} = e^{-i\pi/4} = (1 - i)/\sqrt{2}$, so we have $k = k_r - ik_i$ with $|k_r| = |k_i|$, and

$$k_r = -k_i = \sqrt{\frac{\sigma\mu\omega}{2}}. \quad (11)$$

The wave intensity is attenuated according to $(e^{-i(k_r - ik_i)x})^2 = (e^{-ik_r x} e^{-k_i x})^2 \Rightarrow e^{-2k_i x}$ with a $1/e$ attenuation distance of

$$\frac{1}{2k_i} = \frac{\sqrt{2}}{2\sqrt{\sigma\mu\omega}} = \frac{1}{\sqrt{2\sigma\mu\omega}} \quad (12)$$

which works out to be only 1.67×10^{-9} meters or 16.7 Å, corresponding to the distance of a few atoms! Mirrors need only a very thin metal coating!

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The index of refraction in this case is

$$n = \frac{c}{v_p} = \frac{k}{\omega \sqrt{\mu_0 \epsilon_0}} = \frac{1}{\omega \sqrt{\mu_0 \epsilon_0}} \sqrt{\frac{\sigma \mu \omega}{2}} \frac{(1-i)}{\sqrt{2}} = \sqrt{\frac{\sigma}{\omega \epsilon_0}} \frac{(1-i)}{2} \quad (13)$$

where we have assumed $\mu = \mu_0$ or $\chi_m \ll 1$. For aluminum with green light, we have $n = 16.7(1-i)$.

Reflection coefficients for metals

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The Fresnel equations gave reflection coefficients of

$$r_{\text{TE}} = \frac{\cos \theta - \sqrt{n^2 - \sin^2 \theta}}{\cos \theta + \sqrt{n^2 - \sin^2 \theta}} \quad (14)$$

$$r_{\text{TM}} = \frac{n^2 \cos \theta - \sqrt{n^2 - \sin^2 \theta}}{n^2 \cos \theta + \sqrt{n^2 - \sin^2 \theta}} \quad (15)$$

If we have $n \gg 1$, the $\sin \theta$ and $\cos \theta$ terms will be small compared to n and the reflectivity will approach $R \rightarrow 1$.

Waves from point sources

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- The wave equation for a plane wave is

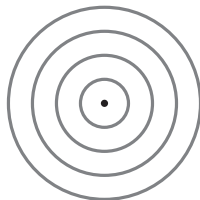
$$\psi = \psi_0 \exp \left[-i(\vec{k} \cdot \vec{z} - \omega t) \right]. \quad (16)$$

- For a spherical wave, the wave equation is

$$\psi = \psi_0 \frac{\lambda}{r} \exp \left[-i(kr - \omega t) \right]. \quad (17)$$

Notice that k is no longer a vector because the spherical wave goes every which way; no direction is defined.

- How can we connect the two?



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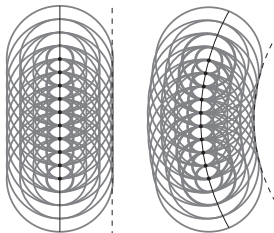
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- Christian Huygens (1629–1695): consider many point sources placed next to each other and in phase. Looks like a plane wave!
- Consider many point sources but with a phase delay/advance, and also magnitude modulation, that depends on position. Refer to this magnitude and phase modulation (which is complex) as $\tilde{g}(x_0, y_0)$.
- In other words, we treat each point in the input plane $(x_0, y_0, 0)$ as a Huygens point source with amplitude $\tilde{g}(x_0, y_0)$.



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To get the amplitude $\psi(x, y, z)$ at a downstream point (x, y, z) , we want to add up all the Huygens point sources (ignoring the time dependence term $\exp[i\omega t]$):

$$\psi(x, y, z) = \psi_0 \frac{\lambda}{A} \int_{x_0} \int_{y_0} \tilde{g}(x_0, y_0) \frac{\exp[-ikr]}{r} \cos \theta. \quad (18)$$

The $1/A$ term is for an integration area to cancel out $\int \int dx_0 dy_0$, and the $\cos \theta$ term is an obliquity factor which we can normally ignore. Since ψ is an amplitude (amplitude=magnitude $\cdot \exp[i\text{phase}]$), the irradiance E is given by $E = \psi \psi^\dagger$.

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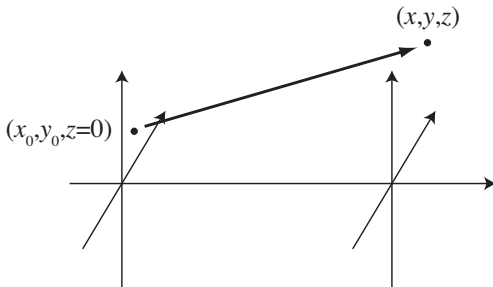
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The radius r from the spherical wave source is given by

$$r = \sqrt{z^2 + (x - x_0)^2 + (y - y_0)^2} = z \sqrt{1 + \frac{(x - x_0)^2}{z^2} + \frac{(y - y_0)^2}{z^2}}. \quad (19)$$



Propagation distances

Again, from Eq. 19 we have

$$r = \sqrt{z^2 + (x - x_0)^2 + (y - y_0)^2} = z \sqrt{1 + \frac{(x - x_0)^2}{z^2} + \frac{(y - y_0)^2}{z^2}}$$

In the limit of $[(x - x_0)^2 + (y - y_0)^2] \ll z^2$, we can write this as

$$\begin{aligned} r &\simeq z \left[1 + \frac{(x - x_0)^2}{2z^2} + \frac{(y - y_0)^2}{2z^2} - \frac{(x - x_0)^4}{8z^4} - \frac{(y - y_0)^4}{8z^4} + \dots \right] \\ &\simeq z \left[1 + \frac{x^2 + y^2}{2z^2} + \frac{x_0^2 + y_0^2}{2z^2} - \frac{xx_0 + yy_0}{z^2} \right] \end{aligned} \quad (20)$$

The second version of the above assumes the *Fresnel approximation*, where we ignore the x^4/z^4 -type terms. Let $\rho = \sqrt{(x - x_0)^2 + (y - y_0)^2}$ represent transverse distances; the Fresnel approximation assumes

$$\frac{2\pi z}{\lambda} \frac{\rho^4}{8z^4} \ll \frac{\pi}{2} \quad \text{or} \quad z^3 \gg \frac{\rho^4}{2\lambda} \quad (21)$$

Numerical example

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- Again, the Fresnel approximation assumes $z^3 \gg \rho^4/(2\lambda)$. If we say that $\rho=0.5$ mm and $\lambda = 500$ nm, we require $z^3 \gg (0.4\text{mm})^3$.
- Since the numerical aperture of a lens is defined as $\text{N.A.} = n \sin \theta$, where θ is the angle subtended by the lens relative to the optical axis, in this example we effectively have $\text{N.A.} \ll 1 \sin(\arctan \rho/z)$ or $\text{N.A.} < 0.4$ if we pick $z > 1$ mm.
 - This means that high resolution microscope objectives which have large N.A. must be designed without the use of the Fresnel approximation.
 - Note: one can relate the numerical aperture and the “ f number” or $f^\#$ —which is the focal length divided by diameter—of a lens with $\text{N.A.} = 2/f^\#$.

Fresnel approximation II

Again, we want to write the expression of Eq. 18 of

$$\psi(x, y, z) = \psi_0 \frac{\lambda}{A} \int_{x_0} \int_{y_0} \tilde{g}(x_0, y_0) \frac{\exp[-ikr]}{r} \cos \theta$$

using the Fresnel approximation version (Eq. 20) of expanding the source-to-measurement distance r giving

$$kr \simeq \frac{2\pi z}{\lambda} \left[1 + \frac{x^2 + y^2}{2z^2} + \frac{x_0^2 + y_0^2}{2z^2} - \frac{xx_0 + yy_0}{z^2} \right]$$

We'll use this expansion for r in the $\exp[ikr]$ phase term, while in the $1/r$ magnitude terms we'll simply use $1/z$. We then have

$$\begin{aligned} \psi(x, y, z) &= \psi_0 \frac{\lambda}{z} \frac{1}{A} \int_{x_0} \int_{y_0} \tilde{g}(x_0, y_0) \\ &\quad \exp \left[-i \frac{2\pi z}{\lambda} - i\pi \frac{x^2 + y^2}{\lambda z} - i\pi \frac{x_0^2 + y_0^2}{\lambda z} + i2\pi \frac{xx_0 + yy_0}{\lambda z} \right] \end{aligned} \quad (22)$$

Fresnel approximation III

Again, we have from Eq. 22 the expression

$$\begin{aligned}\psi(x, y, z) = & \psi_0 \frac{\lambda}{z} \frac{1}{A} \int_{x_0} \int_{y_0} \tilde{g}(x_0, y_0) \\ & \exp \left[-i \frac{2\pi z}{\lambda} - i\pi \frac{x^2 + y^2}{\lambda z} - i\pi \frac{x_0^2 + y_0^2}{\lambda z} + i2\pi \frac{xx_0 + yy_0}{\lambda z} \right]\end{aligned}$$

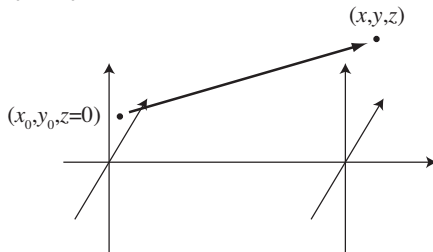
Look at the terms that depend on only x and y : they do not depend on the variables of integration, so we can pull them out of the integral, giving

$$\begin{aligned}\psi(x, y, z) = & \psi_0 \frac{\lambda}{z} \frac{1}{A} \exp \left[-i \frac{2\pi z}{\lambda} \right] \exp \left[-i\pi \frac{x^2 + y^2}{\lambda z} \right] \\ & \int_{x_0} \int_{y_0} \tilde{g}(x_0, y_0) \exp \left[-i\pi \frac{x_0^2 + y_0^2}{\lambda z} \right] \exp \left[i2\pi \frac{xx_0 + yy_0}{\lambda z} \right]\end{aligned} \quad (23)$$

This is the Fresnel-Kirchoff diffraction equation. The prefactor phase terms only matter if we talk about light amplitudes; if we're just using ψ to calculate $I = \psi^* \psi$, we can forget about those phase factors outside the integral.

The Fraunhofer approximation

- What if the object at the input plane is a relatively small pinhole, such that $(x_0^2 + y_0^2)/(\lambda z)$ never reaches a very large value?



- This condition can be written as

$$z \gg 4 \frac{x_0^2 + y_0^2}{\lambda} \quad (24)$$

If we again use $x_0 = 0.4$ mm and $\lambda = 500$ nm, we require $z \gg 2$ mm. We might satisfy this condition in many cases! This condition is known as the *Fraunhofer approximation*.

- We'll also ignore the phase factor $\exp[-i2\pi z/\lambda]$, since it just tells us that the wavefield changes phase by 2π every time we travel a wavelength in distance.

Fraunhofer approximation II

In the Fraunhofer approximation of Eq. 24, and ignoring phase factors outside the integral because they will disappear when calculating $I = \psi^* \psi$, we can write the Fresnel-Kirchoff diffraction integral of Eq. 23 as

$$\psi(x, y, z) \simeq \psi_0 \frac{\lambda}{z} \frac{1}{A} \int_{x_0} \int_{y_0} \tilde{g}(x_0, y_0) \exp \left[i 2 \pi \left(\frac{x x_0}{\lambda z} + \frac{y y_0}{\lambda z} \right) \right] dx_0 dy_0 \quad (25)$$

Remember that this just results from adding up all the Huygens point sources with their magnitude and phase variations $\tilde{g}(x_0, y_0)$. The form of this equation should ring a bell, however!

